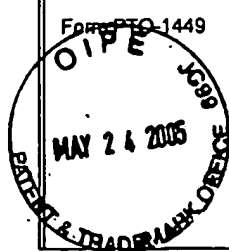


Sheet 1 of 1

Form PTO-1449				ATTY. DOCKET NO. MI22-2295		SERIAL NO. 10/733,181		
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				APPLICANT Micron Technology, Inc.				
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				FILING DATE December 10, 2003		GROUP 2812		
U.S. PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AC	AA	2001/0012223	08/01	Kohyama				
	AB	2002/0030221	03/02	Sandhu et al.				
	AC	2002/0098654	07/02	Durcan et al.				
	AD	2002/0153614	10/02	Ema et al.				
	AE	2003/0178684	09/03	Nakamura				
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
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							Yes	No
AC	AJ	2004/ 027898	08/04	PCT Search Report				
	AK	2004/ 040252	12/04	PCT Search Report				
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
AC	AM	Kim, D.H. et al., "A Mechanically Enhanced Storage Node for Virtually Unlimited Height (MESH)						
		Capacitor Aiming at Sub 70nm DRAMs", IEEE Jan. 2004, pp. 69-72.						
EXAMINER		DATE CONSIDERED						
		12/21/05						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MI22-2295	SERIAL NO. 10733,181
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: H. Montgomery Manning et al.	
		FILING DATE December 10, 2003	GROUP 2812

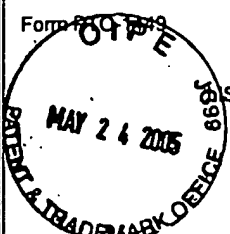


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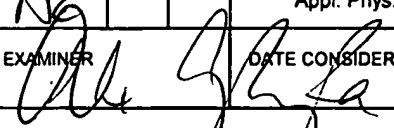
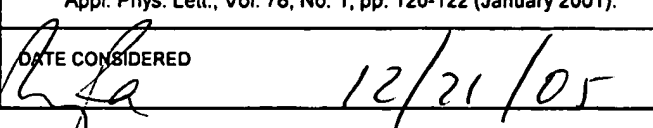
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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
Ac	AD	DE 4447804	1/2002	Germany			Abstract	
	AE							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
Ac	AF		J. P. O'Sullivan et al., <i>The morphology and mechanism of formation of porous anodic films on aluminium</i> , PROC. ROY. SOC. LOND. A, Vol. 317, pp. 511-543 (1970)
	AG		S. Shingubara, <i>Fabrication of nanomaterials using porous alumina templates</i> , J. NANOPARTICLE RES., Vol. 5, pp. 17-30 (2003).
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	AI		J. Liang et al., <i>Nonlithographic Fabrication of Lateral Superlattices for Nanometric Electromagnetic-Optic ...</i>
			IEEE J. SELECTED TOPICS IN QUANTUM ELECTRON., Vol. 8, No. 5, pp. 998-1008 (Sep/Oct 2002).
	AJ		V. V. Konovalov et al., <i>Chemistry of Materials</i> , CHEM. MATER., Vol. 11, No. 8, pp. 1949-1951 (August 1999).
Ac	AK		H. Masuda et al., <i>Highly ordered nanochannel-array architecture in anodic alumina</i> , App. Phys. Lett, Vol. 71, No. 19, pp. 2770-2772 (November 1997).
EXAMINER	DATE CONSIDERED		
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 608. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			

Form 800 7/9 	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2295	SERIAL NO. 10/733,181
			APPLICANT: H. Montgomery Manning et al.	
	LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			FILING DATE December 10, 2003

U.S. PATENT DOCUMENTS							
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
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FOREIGN PATENT DOCUMENTS								
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							Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AC	AM		D. Crouse et al., <i>Self-Assembled Nanostructures Using Anodized Alumina Thin Films for Optoelectronic Applications</i> , IEEE, pp. 234-235 (1999).
	AN		A. Nadeem et al., <i>Fabrication of Microstructures Using Aluminum Anodization Techniques</i> , pp. 274-277 (pre-2004).
AG	AO		C. Y. Liu et al., <i>Ordered anodic alumina nanochannels on focused-ion-beam-prepatterned aluminum surfaces</i> , Appl. Phys. Lett., Vol. 78, No. 1, pp. 120-122 (January 2001).
EXAMINER		DATE CONSIDERED	
			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			


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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: H. Montgomery Manning et al.	
		FILING DATE December 10, 2003	GROUP 2834

U.S. PATENT DOCUMENTS							
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
AC	AA	6,204,143	3/2001	Roberts et al.			
	AB	6,180,450	1/2001	Dennison			
	AC	5,340,763	8/1994	Dennison			
	AD	6,403,442	6/2002	Reinberg			
	AE	6,037,218	3/2000	Dennison et al.			
	AF	5,652,164	7/1997	Dennison et al.			
	AG	5,498,562	12/1996	Dennison et al.			
	AH	5,401,681	3/1995	Dennison et al.			
AC	AI	5,605,857	2/1997	Jost et al.			

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Examiner's Initials		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
AC	AJ	DE 4447804 C2	1/24/2002	Germany (Abstract)				X
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)		
AC	AM	PCT/US2004/027898; Filed: 8/26/2004; PCT Search Report mailed 2/28/2005; 4 pp.
AC	AN	"Novel Robust Cell Capacitor (Leaking Exterminated Ring Type Insulator) And New Storage Node Contact (Top Spacer Contact) For 70nm DRAM Technology And Beyond"; Park et al.;
AC		2004 Symposium on VLSI Technology Digest of Technical Papers; 7/2004; pp. 34-35.
EXAMINER		DATE CONSIDERED
AC		12/21/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
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		Document Number	Date	Country	Class	Subclass	Translation	
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				EV549568	325			
	AJ							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
Ac	AM		Banhart, <i>Aluminum Foams: On the Road to Real Applications</i> , MRS BULLETIN, pp. 290-295 (April 2003).
Ac	AN		Gibson et al., <i>Cellular Solids</i> , MRS BULLETIN, pp. 270-274 (April 2003).
Ac	AO		Green et al., <i>Cellular Ceramics: Intriguing Structures, Novel Properties, and Innovative Applications</i> , MRS BULLETIN, pp. 296-300 (April 2003).
EXAMINER		DATE CONSIDERED	
[Signature]		12/21/05	

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AC	AM		Green et al., <i>The Structure and Applications of Cellular Ceramics</i> , WEB EXTRA, 10 pages (April 2003).
	AN		Karp et al., <i>Scaffolds for Tissue Engineering</i> , MRS Bulletin, pp. 301-306 (April 2003).
AC	AO		Kraynik, <i>Foam Structure: From Soap Froth to Solid Foams</i> , MRS BULLETIN, pp. 275-276 (April 2003).
EXAMINER	DATE CONSIDERED 12/21/05		

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							Yes No
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AC	AM		Maire et al., <i>In Situ X-Ray Tomography Measurements of Deformation in Cellular Solids</i> , MRS BULLETIN, pp. 284-289 (April 2003).
	AN		Oh et al., <i>Preparation and Pore-Characteristics Control of Nano-Porous Materials Using Organometallic Building Blocks</i> , 4 CARBON SCIENCE, No. 1, pp. 1-9 (March 2003).
AO			Onck, <i>Scale Effects in Cellular Metals</i> , MRS BULLETIN, pp. 279-283 (April 2003).
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		FILING DATE December 19, 2003	GROUP 2834

U.S. PATENT DOCUMENTS							
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							Yes No
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AC	AM		Park et al., <i>Block Copolymer Lithography: Periodic Arrays of $\sim 10^{11}$ Holes in 1 Square Centimeter</i> , 276 Science, pp. 1401-1404 (May 30, 1997).
	AN		Tsukada et al., <i>Preparation and Application of Porous Silk Fibroin Materials</i> , 54 JOURNAL OF APPLIED POLYMER SCIENCE, pp. 507-514 (1994).
AO			
EXAMINER		DATE CONSIDERED	
AC		12/21/05	

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